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RESPONSE UNDER 37 C.F.R. § 1.116 -EXPEDITED PROCEDUREEXAMINING GROUP ART GROUP UNIT 1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Jammy et al.

Examiner: Estrada, Michelle

Serial No: 09/363,523

Group Art Unit: 2823

Filed: July 29, 1999

Docket: 99-P-7722-US (8055-98)

For: METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE

This is a response to a Final Office Action mailed on June 28, 2004. Please consider the following remarks to the above-identified application:

CERTIFICATE OF MAILING 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Mail Stop: Non-Fee Amendment, Commissioner for Patents, P.O. Box 1459, Alexandria, VA 22313-1450 on August 27, 2004.

Dated: 27 august 2008

Thomas W. McNall